## Notice of References Cited Application/Control No. 10/814,519 Applicant(s)/Patent Under Reexamination VASILEV, DIMCE Examiner Cloud K. Lee Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-3,704,002	11-1972	Skarzynski, Maciej Stanislaw	251/149.6
*	В	US-6,009,895	01-2000	Wass et al.	137/223
*	U	US-5,076,328	12-1991	Lyon, David L.	138/93
*	D	US-2002/0036015	03-2002	Miyajima et al.	137/543.23
*	Е	US-3,799,589	03-1974	Boelkins, Wallace G.	285/281
*	F	US-6,517,119	02-2003	Thomas, Paul Bruce	285/276
*	G	US-2,268,119	12-1941	HONSTETTER ARI L; et. al.	137/543.13
*	Η	US-6,447,017	09-2002	Gilbreath et al.	285/89
*	-	US-5,911,235	06-1999	Henderson et al.	135/85
*	J	US-3,835,884	09-1974	Ishikawa et al.	137/550
	К	US-			
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν					
	0					
	Ρ					
	σ			- 10		
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.